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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary) | | Application Number | |
| | | Filing Date | |
| | | First Named Inventor | Liang Liu |
| | | Art Unit | |
| | | Examiner Name | |
| Sheet 1 of 2 | Attorney Docket Number | | |

| U.S. PATENT DOCUMENTS | | | | | |
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| Examiner Initials ² | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
| | | Number - Kind Code ³ (if known) | | | |
| | 1 | US- 6,232,706 | 5/15/2001 | The Board of Trustees of the Leland Stanford Junior University | |
| | 2 | US- 6,515,415 | 2/4/2003 | Samsung SDI Co., Ltd. | |
| | 3 | US- 2003/0044537 | 3/6/2003 | Yu-Yang Chang, Jyh-Rong Sheu, Chun-Tao Lee | |
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| | | Country Code ³ - Number ⁴ - Kind Code ⁵ (if known) | | | | |
| | 1 | CN 00121140 | 3/7/2001 | Li Tiezhen, Iljin Nanotech Co., Ltd. | | |
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| Examiner Signature | Date Considered |
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¹ Applicant's unique citation designation number (optional). ² See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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